

Title (en)

ELECTRON SOURCE WITH MICROTIPS, WITH FOCUSING GRID AND HIGH MICROTIP DENSITY, AND FLAT SCREEN USING SAME

Title (de)

MIKROSPITZEN-ELEKTRONENQUELLE MIT FOKUSSIERUNGSGITTER UND HOHER MIKROSPITZENDICHTE UND FLACHSCHIRM UNTER VERWENDUNG EINER SOLCHEN QUELLE

Title (fr)

SOURCE D'ELECTRONS A MICROPOINTES, A GRILLE DE FOCALISATION ET A DENSITE ELEVEE DE MICROPOINTES, ET ECRAN PLAT UTILISANT UNE TELLE SOURCE

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Application

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Abstract (en)

[origin: FR2769751A1] The upper focussing layer is set back from the extraction layer with a series of curved formations providing good focussing.

IPC 8 full level

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